

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/802,225	LIM ET AL.	
Examiner	Art Unit	
EDMUND H. LEE	1791	

SEARCHED					
Class	Subclass	Date	Examiner		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
264/209.3,234,235,210.1 ,211.2,211.12,211.13,34 5,346,348		10/22/2010	EHL	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
UPDATED	10/22/2010	EHL		
264/209.3,234,235,210.1,211.2,211.1 2,211.13,345,346,348	10/22/2010	EHL		